

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	1	anistropic adj conductive near substrate	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/27 16:14
L2	2	US-6344156-\$.DID.	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/27 15:22
L3	22	anistropic near substrate	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/27 15:41
L4	20	US-4307505-\$.DID. OR US-5469613-\$.DID. OR US-5647119-\$.DID. OR US-5934137-\$.DID. OR US-5983489-\$.DID. OR US-6293004-\$.DID. OR US-6591487-\$.DID. OR US-6594888-\$.DID. OR US-6671944-\$.DID. OR US-6708396-\$.DID.	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/27 15:41
L5	2	"6344156".pn.	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/27 16:03
L6	5	("4740657"   "5336443"   "6034331").PN. OR ("6344156").URPN.	US-PGPUB; USPAT; USOCR	OR	ON	2006/02/27 16:04
L7	81	("4740657").URPN.	USPAT	OR	ON	2006/02/27 16:14
L8	37	anistropic near conductive and substrate	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/27 16:16
L9	1	29/830.ccls. and anistropic	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/27 16:19
L10	1	Hsinchu.inv.	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/27 16:31
L11	103	semiconductor near substrate and pins and back near plate	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/27 16:31
L12	12	semiconductor near substrate and pins and liquid adj compound and plate	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/27 16:41

## EAST Search History

L13	0	substrate and pins and liquid adj compound and back near holder	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/27 16:43
L14	33	substrate and pins and compound and back near holder	USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/27 16:43